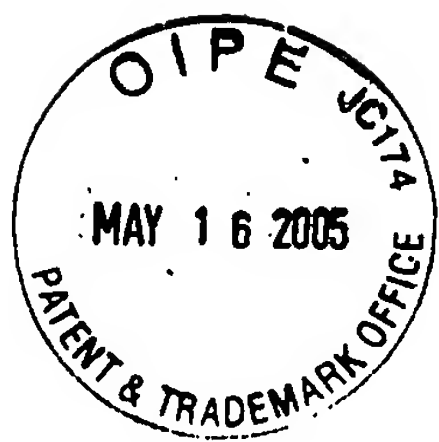


AF/Jan

MS AF
REPLY UNDER 37 C.F.R. § 1.116
EXPEDITED PROCEDURE
EXAMINING GROUP

AMENDMENT TRANSMITTAL LETTER				Docket No. 3313-1048P	
Application No. 10/690,503-Conf. #006047	Filing Date October 23, 2003	Examiner C. F. F. Lam	Art Unit 1775		
Applicant(s): I-Cherng CHEN et al.					
Invention: MATERIAL WITH SURFACE NANOMETER FUNCTIONAL STRUCTURE AND METHOD OF, etc.					
MS AF Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450					
Transmitted herewith is an amendment in the above-identified application. The fee has been calculated and is transmitted as shown below.					
CLAIMS AS AMENDED					
	Claims Remaining After Amendment	Highest Number Previously Paid	Number Extra Claims Present	Rate	
Total Claims	18	- 37 =		x	
Independent Claims	2	- 4 =		x	
Multiple Dependent Claims (check if applicable) <input type="checkbox"/>					
Other fee (please specify):					
TOTAL ADDITIONAL FEE FOR THIS AMENDMENT:					0.00
<input checked="" type="checkbox"/> Large Entity <input type="checkbox"/> Small Entity					
<input checked="" type="checkbox"/> No additional fee is required for this amendment.					
<input type="checkbox"/> Please charge Deposit Account No. _____ in the amount of \$ _____. A duplicate copy of this sheet is enclosed.					
<input type="checkbox"/> A check in the amount of \$ _____ to cover the filing fee is enclosed.					
<input type="checkbox"/> Payment by credit card. Form PTO-2038 is attached.					
<input checked="" type="checkbox"/> The Director is hereby authorized to charge and credit Deposit Account No. <u>02-2448</u> as described below. A duplicate copy of this sheet is enclosed.					
<input checked="" type="checkbox"/> Credit any overpayment.					
<input checked="" type="checkbox"/> Charge any additional filing or application processing fees required under 37 CFR 1.16 and 1.17.					
 Joe McKinney Muncy Attorney Reg. No.: 32,334				Dated: <u>May 16, 2005</u>	
BIRCH, STEWART, KOLASCH & BIRCH, LLP 8110 Gatehouse Rd Suite 100 East P.O. Box 747 Falls Church, Virginia 22040-0747 (703) 205-8026					



**MS AF
REPLY UNDER
37 C.F.R. § 1.116
EXPEDITED PROCEDURE
EXAMINING GROUP 1775**

PATENT
3313-1048P

IN THE U.S. PATENT AND TRADEMARK OFFICE

Applicant: CHEN, I-Cherng et al. Conf.: 6047
Appl. No.: 10/690,503 Group: 1775
Filed: October 23, 2003 Examiner: Cathy F.F. LAM
For: MATERIAL WITH SURFACE NANOMETER FUNCTIONAL
STRUCTURE AND METHOD OF MANUFACTURING THE
SAME

REPLY AFTER FINAL UNDER 37 C.F.R. § 1.116

MS AF

Commissioner for Patents
P.O. BOX 1450
Alexandria, VA 22313-1450

May 16, 2005

Sir:

In response to the Examiner's Office Action dated February 14, 2005, Applicants respectfully submit the following amendments and remarks in connection with the above-identified application.

This reply includes

Amendments to the Specification;

Amended Claim set; and

Remarks.